

I hereby certify that this correspondence is being filed via
EFS-Web with the United States Patent and Trademark Office
MAIL STOP: Amendment on April 29, 2009.

TOWNSEND and TOWNSEND and CREW LLP

By: /Nina L. McNeill/
Nina McNeill

PATENT
Attorney Docket No.: 016301-047800US
Client Ref. No.: AMAT No.
007188/DISPLAY/AKT/BG

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Sheng Sun et al.

Application No.: 10/817,611

Filed: April 2, 2004

For: METHOD AND SYSTEM FOR CONTROL
OF PROCESSING CONDITIONS IN
PLASMA PROCESSING SYSTEMS

Customer No.: 57385

Confirmation No. 2449

Examiner: Bashore, Alain L.

Technology Center/Art Unit: 1792

AMENDMENT

MAIL STOP: AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed January 30, 2009 (the "Office Action"),
please enter the following remarks:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this
paper.

Remarks begin on page 8 of this paper.